PTO/SB/21 (09-04)

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Total Number of	Attorney Do	Attorney Docket Number 111548-136408					
ENCLOSURES (Check all that apply)							
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Fee Attached		Licensing-rela	icensing-related Papers			eal Communication to Board ppeals and Interferences	
Amendment/Reply After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement Certified Copy of Priority Document(s) Reply to Missing Parts/ Incomplete Application Reply to Missing Parts under 37 CFR 1.52 or 1.53		Provisional Ap Power of Attor Change of Co Terminal Disc Request for R CD, Number of	Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence Address Ferminal Disclaimer Request for Refund CD, Number of CD(s) Landscape Table on CD		Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Other Enclosure(s) (please Identify below): Return Receipt Postcard		
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT							
Firm Name	SCHWABE, WILLIAMSON & WYATT, P.C.						
Signature Well Elizalewin							
Printed name Angela M. Sagalewicz							
Date	Date 12/27/2005 Reg. No. 56,113						
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In re Application for:

KRICK, DAVID T., ET AL

Application No.: 10/802,378 Assignee: Intel Corporation

Filed: March 17, 2004

IPN: P17261 (Intel Corporation)

For: AIR GRATE

Examiner: Joyce, Harold

Art Group: 3749

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APPELLANT'S APPEAL BRIEF: REVISION PER NOTIFICATION OF NON-COMPLIANT APPEAL BRIEF

TO THE HONORABLE COMMISSIONER FOR PATENTS:

This paper is filed in response to the Notification of Non-Compliant Appeal Brief ("Notification") mailed November 30, 2005, for appellant's failure to provide a summary of the claimed subject matter as required by 37 C.F.R. §41.37(c)(1)(v). As provided by MPEP §1205.03(B), an appropriate correction for this type of non-compliance is submission of a compliant summary of the claimed subject matter rather than submission of an entire new brief. As such, appellant submits this corrected summary of the claimed subject matter.

Attorney's Docket No.: 111548-136408

Application No.: 10/802,378

V. SUMMARY OF THE CLAIMED SUBJECT MATTER

Various embodiments of the present invention relate to an air grate suitable for use to cover a fab-level air flow opening. For an embodiment, air grate 100 may comprise one or more pieces of one or more materials adapted to partially cover no more than 40% of a spanned area, allowing air to flow through a plurality of openings 102 disposed in the uncovered portion of the spanned area to meet a semiconductor device manufacturing air flow requirement, where each of the openings 102 is sufficiently small to meet a semiconductor device manufacturing fall through object size limitation, and where the one or more materials are further adapted to meet a semiconductor device manufacturing spill protection requirement. See page 4, paragraphs 13-17; page 5, paragraphs 19-20, with reference to figure 2; page 5, paragraph 21, with reference to figures 1a-1c. In alternate embodiments, the one or more pieces of one or more materials may be further adapted to cover the perimeter of the spanned area with an inwardly inclined edge 106 to meet the semiconductor device manufacturing spill protection requirement. See id and page 6, paragraph 28, with reference to figure 1b.

Still further, in other embodiments, air grate 100 may comprise one or more pieces of one or more materials adapted to partially cover no more than 40% of a spanned area, allowing air to flow through a plurality of openings 102 disposed in the uncovered portion of the spanned area to meet a semiconductor device manufacturing air flow requirement, where the one or more materials have a thickness less than 1.0 inch and a tensile strength to meet a semiconductor device manufacturing weight drop requirement of 300 lbs from a height of 2 feet, and where the one or more materials are further adapted to meet a semiconductor device manufacturing spill protection requirement. See pages 4-5, paragraphs 13-18; page 5, paragraphs 19-20, with reference to figure 2; and page 6, paragraph 25, with reference to figures 1a-1c. In various ones of these embodiments, the one or more pieces of one or more materials are further adapted to cover the perimeter of the spanned area with an inwardly inclined edge 106 to meet the semiconductor device manufacturing spill protection requirement. See id and page 6, paragraph 28, with reference to figure 1b.

In other embodiments, an air grate 100 may comprise one or more pieces of one or more materials adapted to partially cover a spanned area to allow air to flow through a plurality of

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Attorney's Docket No.: 111548-136408 Application No.: 10/802,378 openings disposed in the uncovered portion of the spanned area to meet a semiconductor device manufacturing air flow requirement, with the one or more pieces of one or more materials being further adapted to cover the perimeter of the spanned area with an inwardly inclined edge 106 to meet a semiconductor device manufacturing spill protection requirement. *See* pages 4-5, paragraphs 13-18; page 5, paragraphs 19-20, with reference to figure 2; and page 6, paragraph 28, with reference to figure 1b.

Further, methods for making air grate 100 in accordance with embodiments of the present inventions could also comprise forming an air grate mold for use to make an air grate that meets one or more semiconductor manufacturing requirements. See pages 6-7, paragraph 30, with reference to figure 3, block 302. The semiconductor manufacturing requirements could be one or more of (a) a semiconductor device manufacturing spill protection requirement, (b) a semiconductor device manufacturing air flow requirement, (c) a semiconductor device manufacturing weight fall through object size limitation, and (d) a semiconductor device manufacturing weight fall requirement. See id; and pages 4-5, paragraphs 13-18. In various embodiments, methods for making air grate 100 in accordance with embodiments of the present inventions could further comprise injecting a material into the air grate mold to create an air grate. See page 7, paragraph 31, with reference to figure 3, block 304. In various embodiments, methods in accordance with this invention could further comprise removing air grate 100 from the mold. See page 7, paragraph 31, with reference to figure 3, block 306.

CONCLUSION

Appellant respectfully submits that this new summary of the claimed subject matter puts appellant's appeal brief into compliance with 37 C.F.R. §41.37 and requests that the Board of Patent Appeals and Interferences consider the arguments set forth in the previously-filed appeal brief to overrule the Examiner and direct allowance of the rejected claims.

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IPN: P17261 (Intel Corporation)

Appellant previously submitted the appeal brief with a check for \$500 to cover the appeal fee for one other than a small entity as specified in 37 C.F.R. §1.17(c). We do not believe any fees, in particular extension of time fees, are needed with this submission. However, should fees be necessary, please charge Deposit Account No. 500393. In addition, please credit any overages to the same account.

Respectfully submitted,
SCHWABE, WILLIAMSON & WYATT, P.C.

menla Sagaleury

Dated: 12-27-2005

Angela M. Sagalewicz Registration No. 56,113

Pacwest Center, Suite 1900 1211 SW Fifth Avenue Portland, Oregon 97204

Telephone: 503-222-9981